## 502589437 12/04/2013

### PATENT ASSIGNMENT COVER SHEET

Electronic Version v1.1 Stylesheet Version v1.2

EPAS ID: PAT2635605

SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT

### **CONVEYING PARTY DATA**

Name	Execution Date
SHIN-YA MINEGISHI	05/08/2013
SATORU MURAKAMI	04/26/2013
YUSHI MATSUMURA	04/26/2013
KAZUHIKO KOMURA	04/26/2013
YOSHIO TAKIMOTO	04/26/2013
SHIN-YA NAKAFUJI	04/26/2013
KYOYU YASUDA	11/27/2013

### **RECEIVING PARTY DATA**

Name:	JSR Corporation
Street Address:	9-2, Higashi-Shinbashi 1-chome, Minato-ku
City:	Tokyo
State/Country:	JAPAN
Postal Code:	105-8640

#### PROPERTY NUMBERS Total: 1

Property Type	Number
Application Number:	13852120

### **CORRESPONDENCE DATA**

Fax Number: (703)519-9958 Phone: 703-519-9953

Email: htobisawa@dcpatent.com

Correspondence will be sent via US Mail when the email attempt is unsuccessful.

Correspondent Name: MASAYASU MORI

Address Line 1: 44 CANAL CENTER PLAZA, SUITE 322

Address Line 4: ALEXANDRIA, VIRGINIA 22314

ATTORNEY DOCKET NUMBER: P7129US00

PATENT

REEL: 031709 FRAME: 0642

\$40.00 13852120

502589437

NAME OF SUBMITTER: MASAYASU MORI	
Signature: /Masayasu Mori, 47,301/	
Date:	12/04/2013
	This document serves as an Oath/Declaration (37 CFR 1.63).
Total Attachments: 7 source=P7129US00_Declaration_Assignment#page1.tif source=P7129US00_Declaration_Assignment#page2.tif source=P7129US00_Declaration_Assignment#page3.tif source=P7129US00_Declaration_Assignment#page4.tif source=P7129US00_Declaration_Assignment#page5.tif source=P7129US00_Declaration_Assignment#page6.tif source=P7129US00_Declaration_Assignment#page7.tif	

PATENT REEL: 031709 FRAME: 0643

# COMBINED DECLARATION and ASSIGNMENT (37 CFR 1.63) FOR UTILITY OR DESIGN APPLICATION USING AN APPLICATION DATA SHEET (37 CFR 1.76)

Title of Invention	PATTERN-FORMING METHOD, RESIST UNDERLAYER FILM, AND COMPOSITION FOR FORMING RESIST UNDERLAYER FILM	
As the below named inventor, I hereby declare that:  This declaration is directed to:  The attached application, or is directed to:  United States application or PCT international application number 13/852,120 filed on March 28, 2013		
	The above-identified application was made or authorized to be made by me.	
I believe that application.	t I am the original inventor or an original joint inventor of a claimed invention in the	
I hereby acknowledge that any willful false statement made in this declaration is punishable under 18 U.S.C. 1001 by fine or imprisonment of not more than five (5) years, or both.		
	wed and understand the contents of the application and am aware of the duty to disclose to the ad Trademark Office all information known to me to be material to patentability as defined in 56.	
	ASSIGNMENT	
acknowledge business at 9 assigns, and together with countries (in other relevant all improvement on the United S I agree to said invention cause any are everything p	d and valuable consideration, the receipt, sufficiency and adequacy of which are hereby ed, I hereby sell, assign, and transfer to <u>JSR CORPORATION</u> , having a principle place of <u>D-2</u> , <u>Higashi-Shinbashi 1-chome</u> , <u>Minato-ku</u> , <u>Tokyo 105-8640 Japan</u> , and its successors, legal representatives, my entire right, title and interest in and to the invention listed above, in the Application, any and all Patents that may issue for the United States and all foreign cluding the right to claim priority under the terms of the International Convention and any int International Treaties and Arrangements from the aforesaid application), in and to any and ments that are disclosed in the above-noted application, and in and to any reissues, renewals, s, continuation-in-parts, divisionals or extensions thereof that have been or shall be filed in tates and all foreign countries on any of said improvements. The light in any legal proceeding, sign all lawful papers, execute all divisional, and testify in any legal proceeding, sign all lawful papers, execute all divisional, substitute, renewal, and reissue applications, execute all necessary assignment papers to dall Patents to be issued to the assignee, make all rightful oaths, and, generally do ossible to aid said assignee, its successors and assigns, to obtain and enforce proper or said invention in the United States and in any and all foreign countries.	
	ME OF INVENTOR (Given name FAMILY NAME)  Shin-ya MINEGISHI  Date: May 8, 2013	

**PATENT** 

# COMBINED DECLARATION and ASSIGNMENT (37 CFR 1.63) FOR UTILITY OR DESIGN APPLICATION USING AN APPLICATION DATA SHEET (37 CFR 1.76)

Title of Invention	PATTERN-FORMING METHOD, RESIST UNDERLAYER FILM, AND COMPOSITION FOR FORMING RESIST UNDERLAYER FILM		
As the below	As the below named inventor, I hereby declare that:		
This declarat			
is directed to	United States application or PCT international application number 13/852,120 filed on March 28, 2013		
The above-ic	The above-identified application was made or authorized to be made by me.		
I believe that I am the original inventor or an original joint inventor of a claimed invention in the application.			
I hereby acki U.S.C. 1001	nowledge that any willful false statement made in this declaration is punishable under 18 by fine or imprisonment of not more than five (5) years, or both.		
I have reviewed and understand the contents of the application and am aware of the duty to disclose to the US Patent and Trademark Office all information known to me to be material to patentability as defined in 37 CFR § 1.56.			
	ASSIGNMENT		
acknowledge business at 9 assigns, and together with countries (in other relevar all improven continuation the United S I agree th said inventio continuation cause any an everything p	and valuable consideration, the receipt, sufficiency and adequacy of which are hereby ed, I hereby sell, assign, and transfer to <u>JSR CORPORATION</u> , having a principle place of <u>P-2</u> , <u>Higashi-Shinbashi I-chome</u> , <u>Minato-ku</u> . <u>Tokyo 105-8640 Japan</u> , and its successors, legal representatives, my entire right, title and interest in and to the invention listed above, in the Application, any and all Patents that may issue for the United States and all foreign cluding the right to claim priority under the terms of the International Convention and any and international Treatics and Arrangements from the aforesaid application), in and to any and ments that are disclosed in the above-noted application, and in and to any reissues, renewals, s, continuation-in-parts, divisionals or extensions thereof that have been or shall be filed in tates and all foreign countries on any of said improvements. The international treation is to the assignee or its representatives any facts known to me respecting on, and testify in any legal proceeding, sign all lawful papers, execute all divisional, substitute, renewal, and reissue applications, execute all necessary assignment papers to all Patents to be issued to the assignee, make all rightful oaths, and, generally do cossible to aid said assignee, its successors and assigns, to obtain and enforce proper or said invention in the United States and in any and all foreign countries.		
LEGAL NA	ME OF INVENTOR (Given name FAMILY NAME)		
	Satoru MURAKAMI Date: Apr. 26th, 26/3		
Signature	: Satoru Tuurahumi		

## COMBINED DECLARATION and ASSIGNMENT (37 CFR 1.63) FOR UTILITY OR DESIGN APPLICATION USING AN APPLICATION DATA SHEET (37 CFR 1.76)

Title of Invention	PATTERN-FORMING METHOD, RESIST UNDERLAYER FILM, AND COMPOSITION FOR FORMING RESIST UNDERLAYER FILM	
As the below	v named inventor, I hereby declare that:	
This declara	1 1 ' ' ' ' ' ' ' ' ' ' ' ' ' ' ' ' ' '	
io direction to	United States application or PCT international application number <u>13/852,120</u> filed on <u>March 28, 2013</u>	
The above-identified application was made or authorized to be made by me.		
I believe that I am the original inventor or an original joint inventor of a claimed invention in the application.		
	nowledge that any willful false statement made in this declaration is punishable under 18 by fine or imprisonment of not more than five (5) years, or both.	
I have reviewed and understand the contents of the application and am aware of the duty to disclose to the US Patent and Trademark Office all information known to me to be material to patentability as defined in 37 CFR § 1.56.		
	ASSIGNMENT	
For good and valuable consideration, the receipt, sufficiency and adequacy of which are hereby acknowledged, I hereby sell, assign, and transfer to JSR CORPORATION, having a principle place of business at 9-2, Higashi-Shinbashi 1-chome, Minato-ku, Tokyo 105-8640 Japan, and its successors, assigns, and legal representatives, my entire right, title and interest in and to the invention listed above, together with the Application, any and all Patents that may issue for the United States and all foreign countries (including the right to claim priority under the terms of the International Convention and any other relevant International Treaties and Arrangements from the aforesaid application), in and to any and all improvements that are disclosed in the above-noted application, and in and to any reissues, renewals, continuations, continuation-in-parts, divisionals or extensions thereof that have been or shall be filed in the United States and all foreign countries on any of said improvements.  I agree that I will communicate to the assignee or its representatives any facts known to me respecting said invention, and testify in any legal proceeding, sign all lawful papers, execute all divisional, continuation, substitute, renewal, and reissue applications, execute all necessary assignment papers to cause any and all Patents to be issued to the assignee, make all rightful oaths, and, generally do everything possible to aid said assignee, its successors and assigns, to obtain and enforce proper protection for said invention in the United States and in any and all foreign countries.		
LEGAL NA	ME OF INVENTOR (Given name FAMILY NAME)	
Inventor;	Yushi MATSUMURA Date: April, 26th, 2013	
Signature	: Yushi Matsumura	

## COMBINED DECLARATION and ASSIGNMENT (37 CFR 1.63) FOR UTILITY OR DESIGN APPLICATION USING AN APPLICATION DATA SHEET (37 CFR 1.76)

Title of Invention	PATTERN-FORMING METHOD, RESIST UNDERLAYER FILM, AND COMPOSITION FOR FORMING RESIST UNDERLAYER FILM	
As the below named inventor, I hereby declare that:  This declaration is directed to:  The attached application, or is directed to:  United States application or PCT international application number 13/852,120 filed on March 28, 2013		
The above-i	dentified application was made or authorized to be made by me.	
I believe that I am the original inventor or an original joint inventor of a claimed invention in the application.		
I hereby acknowledge that any willful false statement made in this declaration is punishable under 18 U.S.C. 1001 by fine or imprisonment of not more than five (5) years, or both.		
I have reviewed and understand the contents of the application and am aware of the duty to disclose to the US Patent and Trademark Office all information known to me to be material to patentability as defined in 37 CFR § 1.56.		
	ASSIGNMENT	
For good and valuable consideration, the receipt, sufficiency and adequacy of which are hereby acknowledged, I hereby sell, assign, and transfer to JSR CORPORATION, having a principle place of business at 9-2, Higashi-Shinbashi 1-chome, Minato-ku, Tokyo 105-8640 Japan, and its successors, assigns, and legal representatives, my entire right, title and interest in and to the invention listed above, together with the Application, any and all Patents that may issue for the United States and all foreign countries (including the right to claim priority under the terms of the International Convention and any other relevant International Treaties and Arrangements from the aforesaid application), in and to any and all improvements that are disclosed in the above-noted application, and in and to any reissues, renewals, continuations, continuation-in-parts, divisionals or extensions thereof that have been or shall be filed in the United States and all foreign countries on any of said improvements.  I agree that I will communicate to the assignee or its representatives any facts known to me respecting said invention, and testify in any legal proceeding, sign all lawful papers, execute all divisional, continuation, substitute, renewal, and reissue applications, execute all necessary assignment papers to cause any and all Patents to be issued to the assignee, make all rightful oaths, and, generally do everything possible to aid said assignee, its successors and assigns, to obtain and enforce proper protection for said invention in the United States and in any and all foreign countries.		
LEGAL NA	ME OF INVENTOR (Given name FAMILY NAME)	
	Kazuhiko KOMURA Date: 04/26/20/3	
Signature	: Kozupiko Komura	

## COMBINED DECLARATION and ASSIGNMENT (37 CFR 1.63) FOR UTILITY OR DESIGN APPLICATION USING AN APPLICATION DATA SHEET (37 CFR 1.76)

Title of Invention	PATTERN-FORMING METHOD, RESIST UNDERLAYER FILM, AND COMPOSITION FOR FORMING RESIST UNDERLAYER FILM	
As the below	v named inventor, I hereby declare that:	
This declara		
is directed to	United States application or PCT international application number 13/852,120 filed on March 28, 2013	
The above-identified application was made or authorized to be made by me.		
I believe that I am the original inventor or an original joint inventor of a claimed invention in the application.		
I hereby acknowledge that any willful false statement made in this declaration is punishable under 18 U.S.C. 1001 by fine or imprisonment of not more than five (5) years, or both.		
I have reviewed and understand the contents of the application and am aware of the duty to disclose to the US Patent and Trademark Office all information known to me to be material to patentability as defined in 37 CFR § 1.56.		
	ASSIGNMENT	
For good and valuable consideration, the receipt, sufficiency and adequacy of which are hereby acknowledged, I hereby sell, assign, and transfer to <a href="ISR CORPORATION">ISR CORPORATION</a> , having a principle place of business at <a href="9-2">9-2</a> , Higashi-Shinbashi 1-chome, Minato-ku, Tokyo 105-8640 Japan, and its successors, assigns, and legal representatives, my entire right, title and interest in and to the invention listed above, together with the Application, any and all Patents that may issue for the United States and all foreign countries (including the right to claim priority under the terms of the International Convention and any other relevant International Treaties and Arrangements from the aforesaid application, in and to any and all improvements that are disclosed in the above-noted application, and in and to any reissues, renewals, continuations, continuation-in-parts, divisionals or extensions thereof that have been or shall be filed in the United States and all foreign countries on any of said improvements.  I agree that I will communicate to the assignee or its representatives any facts known to me respecting said invention, and testify in any legal proceeding, sign all lawful papers, execute all divisional, continuation, substitute, renewal, and reissue applications, execute all necessary assignment papers to cause any and all Patents to be issued to the assignee, make all rightful oaths, and, generally do everything possible to aid said assignee, its successors and assigns, to obtain and enforce proper protection for said invention in the United States and in any and all foreign countries.		
LEGAL NA	ME OF INVENTOR (Given name FAMILY NAME)	
Inventor	Yoshio TAKIMOTO Date: Apr. 26th, 2013	
Signature	: Toshio Takimoto	

## COMBINED DECLARATION and ASSIGNMENT (37 CFR 1.63) FOR UTILITY OR DESIGN APPLICATION USING AN APPLICATION DATA SHEET (37 CFR 1.76)

· · · · · · · · · · · · · · · · · · ·		
Title of Invention PATTERN-FORMING METHOD, RESIST UNDERLAYER FILM, AND COMPOSITION FOR FORMING RESIST UNDERLAYER FILM		
As the below named inventor, I hereby declare that:		
This declaration  The attached application, or		
United States application or PCT international application number 13/852, filed on March 28, 2013	<u>120</u>	
The above-identified application was made or authorized to be made by me.		
I believe that I am the original inventor or an original joint inventor of a claimed invention in the application.		
I hereby acknowledge that any willful false statement made in this declaration is punishable under 18 U.S.C. 1001 by fine or imprisonment of not more than five (5) years, or both.		
I have reviewed and understand the contents of the application and am aware of the duty to disclose to the US Patent and Trademark Office all information known to me to be material to patentability as defined in 37 CFR § 1.56.		
ASSIGNMENT		
For good and valuable consideration, the receipt, sufficiency and adequacy of which are hereby acknowledged, I hereby sell, assign, and transfer to JSR CORPORATION, having a principle place of business at 9-2. Higashi-Shinbashi 1-chome, Minato-ku, Tokyo 105-8640 Japan, and its successors, assigns, and legal representatives, my entire right, title and interest in and to the invention listed above, together with the Application, any and all Patents that may issue for the United States and all foreign countries (including the right to claim priority under the terms of the International Convention and any other relevant International Treaties and Arrangements from the aforesaid application), in and to any and all improvements that are disclosed in the above-noted application, and in and to any reissues, renewals, continuations, continuation-in-parts, divisionals or extensions thereof that have been or shall be filed in the United States and all foreign countries on any of said improvements.  I agree that I will communicate to the assignee or its representatives any facts known to me respecting said invention, and testify in any legal proceeding, sign all lawful papers, execute all divisional, continuation, substitute, renewal, and reissue applications, execute all necessary assignment papers to cause any and all Patents to be issued to the assignee, make all rightful oaths, and, generally do everything possible to aid said assignee, its successors and assigns, to obtain and enforce proper protection for said invention in the United States and in any and all foreign countries.		
LEGAL NAME OF INVENTOR (Given name FAMILY NAME)		
Inventor: Shin-ya NAKAFUJI Date: Apr. 24th, 2013		
Signature: Shin-ya NAKAFUJI		

## COMBINED DECLARATION and ASSIGNMENT (37 CFR 1.63) FOR UTILITY OR DESIGN APPLICATION USING AN APPLICATION DATA SHEET (37 CFR 1.76)

Title of Invention	PATTERN-FORMING METHOD, RESIST UNDERLAYER FILM, AND COMPOSITION FOR FORMING RESIST UNDERLAYER FILM		
As the below named inventor, I hereby declare that:  This declaration is directed to:  The attached application, or is directed to:  United States application or PCT international application number 13/852,120 filed on March 28, 2013			
The above-io	dentified application was made or authorized to be made by me.		
I believe that application.	I believe that I am the original inventor or an original joint inventor of a claimed invention in the application.		
	nowledge that any willful false statement made in this declaration is punishable under 18 by fine or imprisonment of not more than five (5) years, or both.		
	wed and understand the contents of the application and am aware of the duty to disclose to the ad Trademark Office all information known to me to be material to patentability as defined in 56.		
	ASSIGNMENT		
For good and valuable consideration, the receipt, sufficiency and adequacy of which are hereby acknowledged, I hereby sell, assign, and transfer to JSR CORPORATION, having a principle place of business at 9-2, Higashi-Shinbashi I-chome, Minato-ku, Tokyo 105-8640 Japan, and its successors, assigns, and legal representatives, my entire right, title and interest in and to the invention listed above, together with the Application, any and all Patents that may issue for the United States and all foreign countries (including the right to claim priority under the terms of the International Convention and any other relevant International Treaties and Arrangements from the aforesaid application), in and to any and all improvements that are disclosed in the above-noted application, and in and to any reissues, renewals, continuations, continuation-in-parts, divisionals or extensions thereof that have been or shall be filed in the United States and all foreign countries on any of said improvements.  I agree that I will communicate to the assignee or its representatives any facts known to me respecting said invention, and testify in any legal proceeding, sign all lawful papers, execute all divisional, continuation, substitute, renewal, and reissue applications, execute all necessary assignment papers to cause any and all Patents to be issued to the assignee, make all rightful oaths, and, generally do everything possible to aid said assignee, its successors and assigns, to obtain and enforce proper protection for said invention in the United States and in any and all foreign countries.			
LEGAL NA	ME OF INVENTOR (Given name FAMILY NAME)		
	Kyoyu YASUDA Date: Nov. 27th. 2013  Kyoyu Jasuda		

PATENT REEL: 031709 FRAME: 0650

**RECORDED: 12/04/2013**